Supporting Information

Highly Stretchable, Self-adhesive, Ambient-stable, and Widetemperature Adaptable Hydrophobic Ionogels for Wearable Strain Sensor

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Samples	Amount of DAAM/ <i>wt%</i>	Amount of BMIMTFSI/ <i>wt%</i>	Amount of HP-A in DAAM/ <i>wt%</i>
10%-Ionogel-1	10	90	0.2
10%-Ionogel-2	10	90	0.5
10%-Ionogel-3	10	90	1
10%-Ionogel-4	10	90	2
10%-Ionogel-5	10	90	5
15%-Ionogel-1	15	85	0.2
20%-Ionogel-1	20	80	0.2
20%-Ionogel-2	20	80	0.5
20%-Ionogel-3	20	80	1
20%-Ionogel-4	20	80	2
20%-Ionogel-5	20	80	5

Table S1 Composition of the ionogels

Samples	Elongation at break (%)	Tensile strength (kPa)	Young's modulus (kPa)	Toughness (kJ/m ³)
10%-Ionogel-1	1090	98.9	15	420.5
15%-Ionogel-1	1120	126.9	25	761.2
20%-Ionogel-1	1170	142.1	38	872.6
20%-Ionogel-2	830	158.5	188	745.7
20%-Ionogel-3	330	119.1	255	206.0
20%-Ionogel-5	85	59.1	365	26.9





Fig. S1 Photographs showing the WCA of the surface of hydrophobic ionogel.



Fig. S2 Digital pictures of the ionogels in air (a), under water with different time (b-e), and the dried sample (f).



Fig. S3 Strain sweep curve of the sample 10%-Ionogel-1.



Fig. S4 (a) Changes of G' and G'' with frequency for the 20%-Ionogel with HP-A and EGDM. (b) Changes of G' and G'' with temperature for the 20%-Ionogel with HP-A and EGDM.



Fig. S5 Typical monotonic tensile stress-strain curves of the ionogel with HP-A and EGDM.



Fig. S6 Monotonic Tensile stress-strain curves of 20%-Ionogel-2 at -30 °C, 25 °C, and 150 °C.



Fig. S7 The temperature dependence of impedance for 20%-Ionogel-3.



Fig. S8 The temperature dependence of viscosity for (a) 10%-Ionogel-1 and (b) 20%-Ionogel-1.



Fig. S9 Typical lap shear curves of ionogel with various substrates in air.



Fig. S10 The relative resistance $(\Delta R/R_0)$ of the sensors with different content of DAAM (strain=100%).



Fig. S11 The relative resistance variations $(\Delta R/R_0)$ of the sensor at various loading rates.